Record Nr. UNISA996204464603316 1996 IEEE International Conference on Microelectronic Test Structures Titolo [Place of publication not identified], : IEEE, 1996 Pubbl/distr/stampa Descrizione fisica 1 online resource (338 pages) Disciplina 621.3815 Soggetti Integrated circuits Microelectronics Lingua di pubblicazione Inglese **Formato** Materiale a stampa Livello bibliografico Monografia Bibliographic Level Mode of Issuance: Monograph Note generali Sommario/riassunto The papers included in this leading international conference examine test structures for microelectronic devices, their recent progress and future directions. Included is a detailed treatment of current developments in silicon and gallium arsenide microelectronic test structure research, implementation, and applications. Also addressed are advances in device characterization, such as increased miniaturization, reduced operating voltages and reduced power requirements through improved measurement and test techniques. Topics highlighted include: Process Characterization, Dimensional Measurements, Interconnection, SOI & Material Characterization, Reliability, Device Characterization, Capacitance Measurements, Statistics.